

**Amendments to the Specification:**

Kindly replace paragraph [0061] with the following amended paragraph:

[0061] A fifth embodiment of a micro switch according to the present invention is a cantilever switch of a resistively coupled structure, having a structure that the dielectric film 3' on the conductive layer 3 is removed from the structure of the above second embodiment of the present invention. The remaining elements of the micro switch of the fifth embodiment are the same as those of the ~~third~~ second embodiment of the present invention.